

IN THE UNITED STATES PATENT AND TRADEMARK OFFICERECEIVED  
CENTRAL FAX CENTER

JUL 07 2004

Applicant(s): Woo Sik Yoo

Assignee: WaferMasters, Inc.

Title: METHOD OF FORMING AN OXIDE LAYER (As Amended)

Serial No.: 10/085,498

Filing Date: February 26, 2002

Examiner: Jolley, Kirsten

Group Art Unit: 1762

Docket No.: M-11549 US

OFFICIAL

Irvine, California  
July 7, 2004COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Alexandria, VA 22213-1450**PETITION FOR EXTENSION OF TIME**

Dear Sir:

Applicant(s) respectfully petition(s) for a 1-month extension of time within which to respond to the Final Office Action mailed by the U.S. Patent and Trademark Office on April 6, 2004, such extension allowing the undersigned until August 6, 2004 to respond.

Please charge the fee of \$55.00 to the undersigned's Deposit Account No. 50-2257.

Please charge any additional fees or credit overpayment to the above-deposit account. If there are any questions, please call the undersigned at (949) 752-7040.

I hereby certify that this correspondence is being sent by facsimile to (703) 872-9306 on July 7, 2004.

*Tina Kavanaugh*  
Tina Kavanaugh

July 7, 2004

Respectfully submitted,

*David S. Park*

David S. Park  
Attorney for Applicant(s)  
Reg. No. 52,094

LAW OFFICES OF  
MACPHERSON HOWE CHEN  
& WEID LLP

1401 MICHELSON DRIVE  
SUITE 210  
IRVINE, CA 92613  
(949) 752-7040  
FAX (949) 752-7049

-1-

Serial No. 10/123,378

PAGE 1/1 \* RCVD AT 7/7/2004 5:33:11 PM (Eastern Daylight Time) \* SVR:USPTO-EFAXF-1/1 \* DNIS:8729306 \* CSID:9497527049 \* DURATION (mm-ss):05:28  
07/26/2004 FNELSON 00000001 502257 10083498

01 FC:2251

55.00 DA